



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Anthony *et al.*
Serial No.: 09/116,138
Filed: 07/15/98
For: High Permittivity Silicate Gate Dielectric

Docket: TI-249
Examiner: A. Mai
Art Unit: 2814

RECEIVED
AUG 22 2002
TECHNOLOGY CENTER 2809

#25 dxt(2)

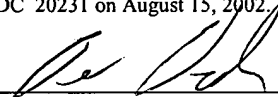
M. Brunson
8/28/02

Petition For Extension of Time Under 37 C.F.R. § 1.136

August 15, 2002

Assistant Commissioner For Patents
Washington, D. C. 20231

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8
I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
addressed to: Assistant Commissioner for Patents, Washington,
DC 20231 on August 15, 2002.

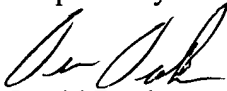

David Denker Reg. No. 40,987

Dear Sir:

Applicants respectfully petition the Commissioner for a two month extension of the shortened statutory period for response in the above-identified application.

Please charge this and any other required fee—including additional extension of time fees—to the deposit account of Texas Instruments Incorporated, Account No. 20-0668. Any further necessary extension of time is hereby requested. **Two additional copies of this sheet are enclosed.**

Respectfully submitted,


David Denker
Reg. No. 40,987

Texas Instruments Incorporated
P. O. Box 655474, MS 3999
Dallas, Texas 75265
(972) 917-4388
Fax (972) 917-4418

08/21/2002 AWONDAF1 00000097 200668 09116138

02 FC:116 400.00 CH